

LC-479/PCT/US
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
CHU, Hsien-Kun) : Examiner: NYA
Application No.: NYA) : Group Art Unit: NYA
 : Confirmation No.: NYA
Filed: Concurrently Herewith :
For: FAST MOISTURE CURING :
AND UV-MOISTURE DUAL)
CURING COMPOSITIONS : February 14, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §§ 1.51(b), 1.56, 1.97 and 1.98, Applicant draws the Examiner's attention to the document that appears listed on the attached Form PTO-1449. Copies of the U.S. patent documents are not enclosed, though a copy of the other document is enclosed.

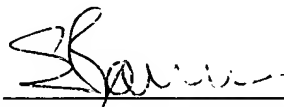
Applicant respectfully requests that this document be considered by the Examiner, made of record herein, listed on the "Notice of References Cited" to be issued in this application and printed on any patent which may issue from this application. Applicant also respectfully requests that a copy of the attached Form PTO-1449, initialed by the Examiner, be returned to

Applicant's attorney together with the next communication indicating that these documents have in fact been considered.

Applicant requests a prompt and favorable examination of the instant application.

Applicant's undersigned attorney may be reached by telephone at (860) 571-5001 or by facsimile at (860) 571-5028. All correspondence should continue to be directed to the address given below.

Respectfully submitted,



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FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets if Necessary) <small>(37 CFR 1.98(b))</small>	ATTORNEY DOCKET NO.: LC-479/PCT/US	APPLICATION NO.: NYA
	APPLICANT: CHU, Hsien-Kun	
	FILING DATE: Concurrently Herewith	GROUP: NYA

U.S. PATENT DOCUMENTS						
EXAMINER'S INITIAL	PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	4,528,081	07.09.85	Lien, et al.	522	39	
	4,675,346	06.23.87	Lin, et al.	522	39	
	4,699,802	10.13.87	Nakos, et al.	427	515	
	5,340,847	08.23.94	Hanazuka, et al.	522	11	
	5,384,340	01.24.95	Hara, et al.	522	99	
	5,405,888	04.11.95	Takeoka	522	34	
	5,409,963	04.25.95	Takfoka	522	31	
	5,489,622	02.06.96	Hara, et al.	522	99	

NON-U.S. PATENT DOCUMENTS								
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB CLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)			
			Chu, H.K., <u>Silicones and Silicone-Modified Materials</u> , ed. Clarson, et al., American Chemical Society, Washington DC, pp 170-179 (2000)

EXAMINER:	DATE CONSIDERED:
EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.	